# **Special Issue**

# Sensing for In-Process Monitoring of High-Value Manufacturing Processes

## Message from the Guest Editors

This Special Issue aims to bring together research relating to sensing for in-process monitoring of high-value manufacturing processes. We invite you to contribute to this issue by submitting both case studies and research articles focusing on high-value manufacturing processes. This Special Issue will cover papers from a range of manufacturing processes including (but not limited to): surface manufacturing, machining, assembly, and continuous manufacturing. We particularly welcome papers from high-value manufacturing application areas, such as electrical machine manufacture, aerostructure assembly, and surface manufacture.

#### **Guest Editors**

Prof. Dr. Ashutosh Tiwari

Prof. Geraint Jewell

Dr. Divva Tiwari

Dr. Michael Farnsworth

### Deadline for manuscript submissions

closed (20 February 2023)



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### Message from the Editor-in-Chief

Sensors is a leading journal devoted to fast publication of the latest achievements of technological developments and scientific research in the huge area of physical, chemical and biochemical sensors, including remote sensing and sensor networks. Both experimental and theoretical papers are published, including all aspects of sensor design, technology, proof of concept and application. Sensors organizes Special Issues devoted to specific sensing areas and applications each year.

#### Editor-in-Chief

#### Prof. Dr. Vittorio M. N. Passaro

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